

LCMO

From thin films to nanowires

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Groupmeeting 08-09-05

Outline

✓ Introduction

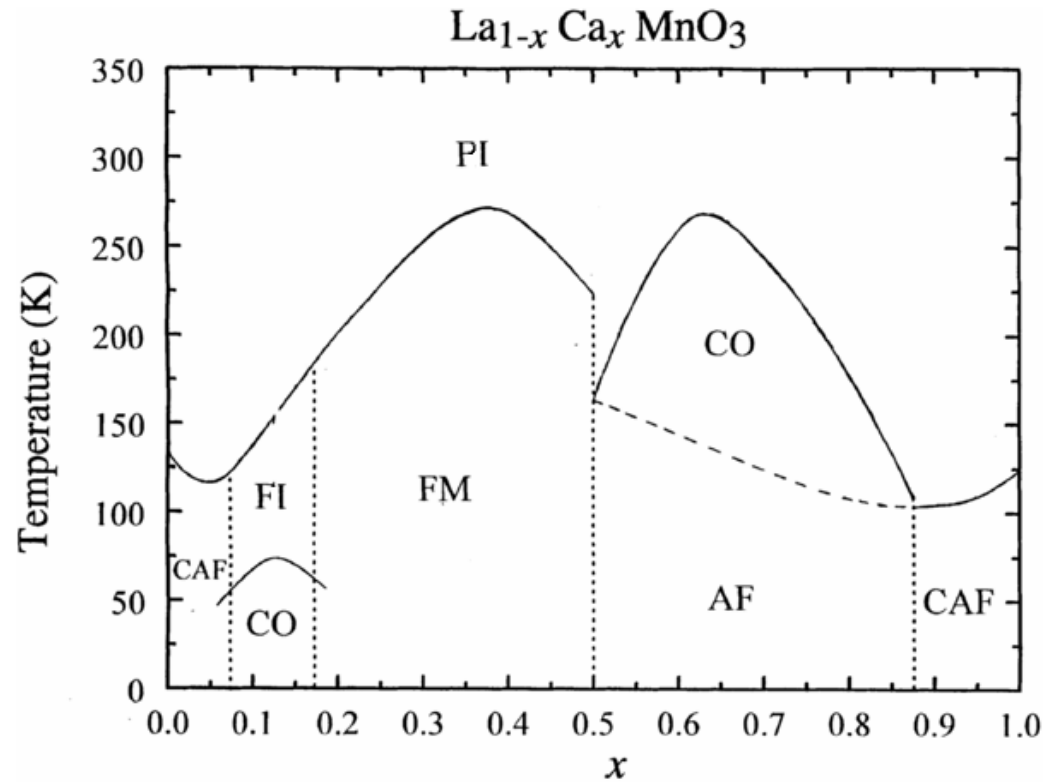
- Complex phase diagram
- Double exchange
- Magnetoresistance

✓ Miscut substrates

✓ Growing LCMO nanowires

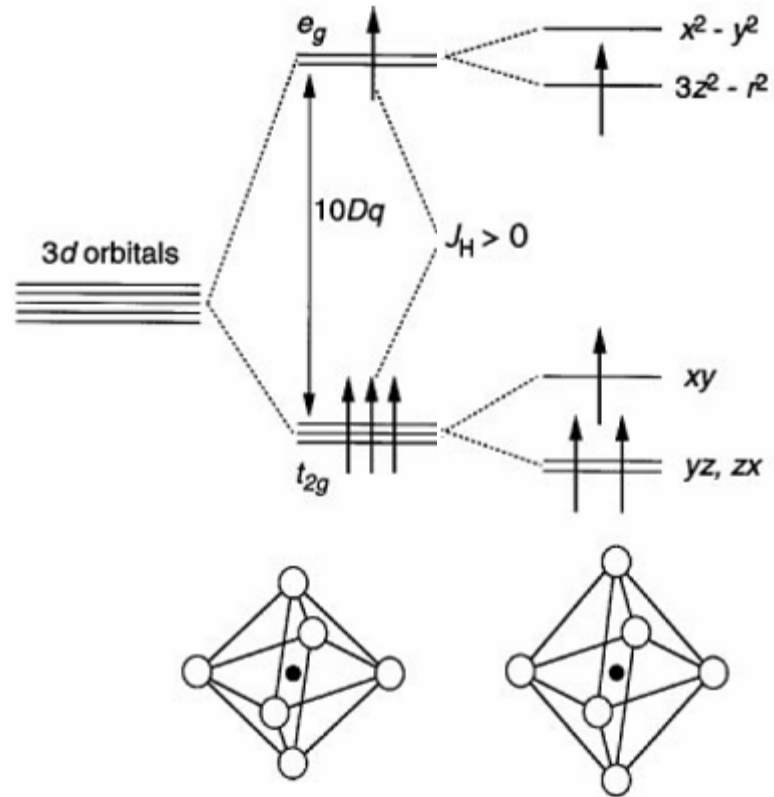
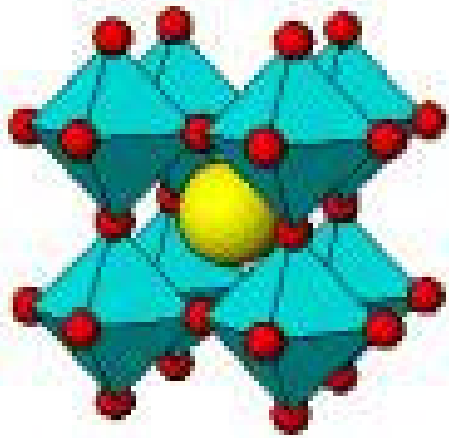
- Sol-gel process with alumina templates
- Pt as contact material

LCMO



- $\text{La}_{0.7}\text{Ca}_{0.3}\text{MnO}_3$: - CMR effect
- 100% polarized ferromagnet
- metal-insulator transition

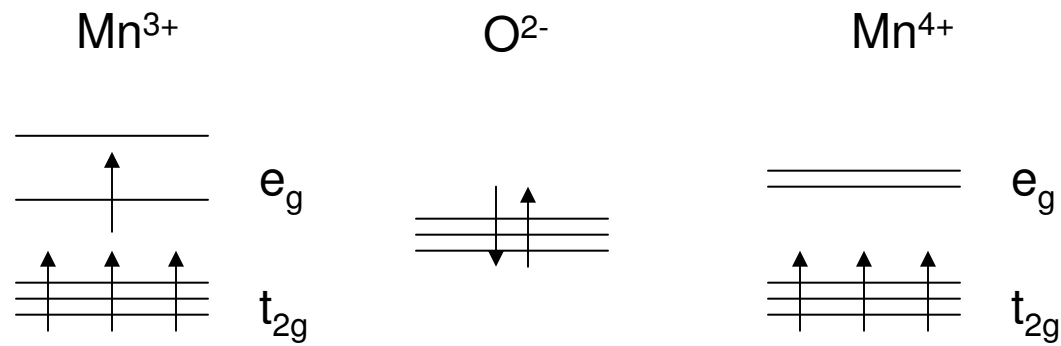
Perovskite lattice



t_{2g} : localized core electrons

e_g : delocalized electron

Double exchange



Hopping mediates the onset of the ferromagnetic state

Double exchange

Hopping rate determined by:

Transfer integral

$$\tilde{t} = t \cos(\Delta\theta_s / 2)$$

$\Delta\theta_s$: difference in spin angle between the Mn ions

One electron bandwidth

$$W \propto \frac{\cos^2(\theta)}{l_{Mn-O}^{3.5}}$$

θ : Mn-O-Mn bond angle, l_{Mn-O} : Mn-O bond length

Jahn Teller distortions

DE model does not explain the localization above T_C

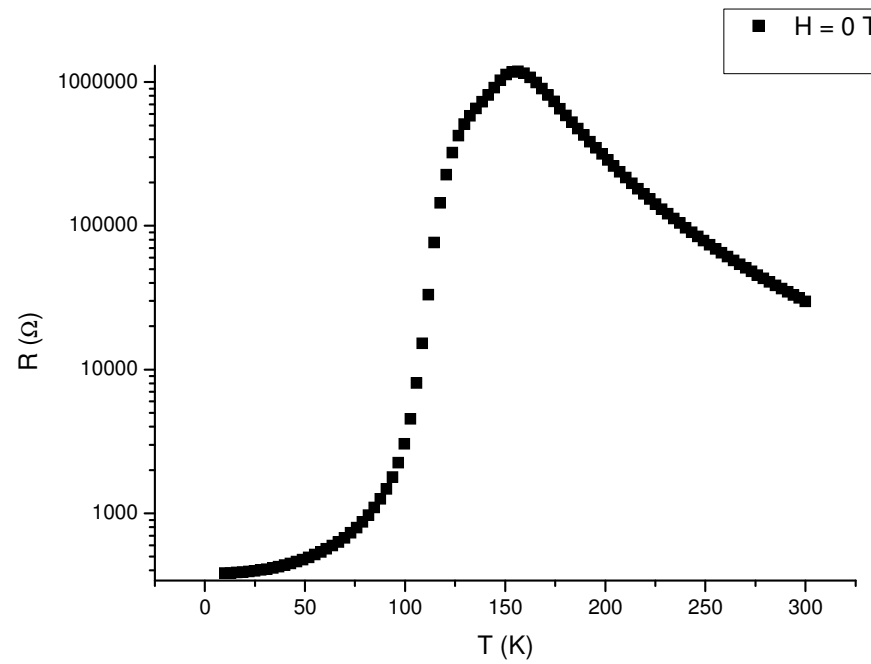
Strong electron-lattice coupling can cause localization

Competition between polaron formation and delocalization due to hybridization which can be described by the ratio,

$$\lambda = \frac{E_{latt}}{t_{eff}}$$

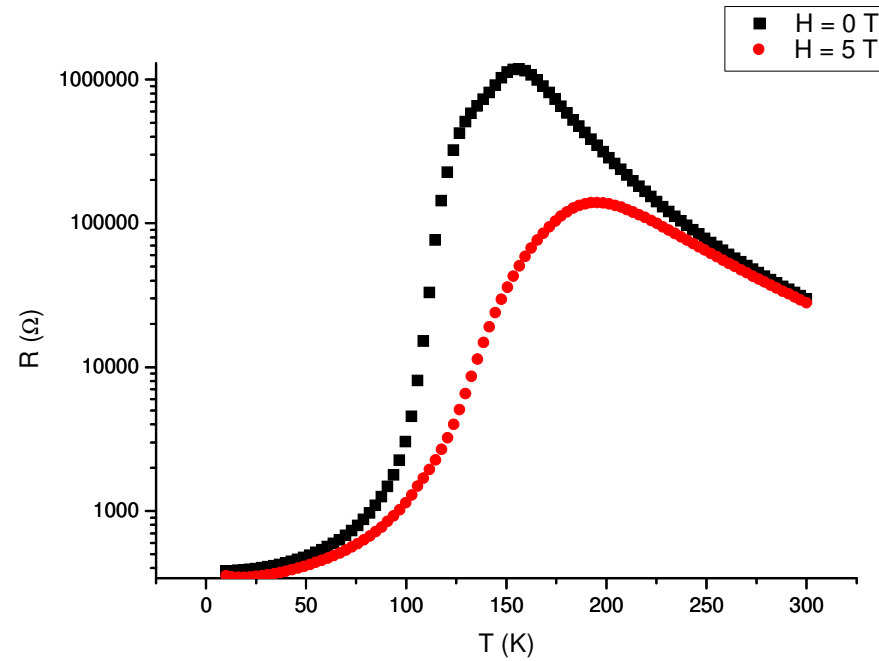
t_{eff} : 'bare' electron kinetic energy,

E_{latt} : energy gained by e-ph coupling without hybridization

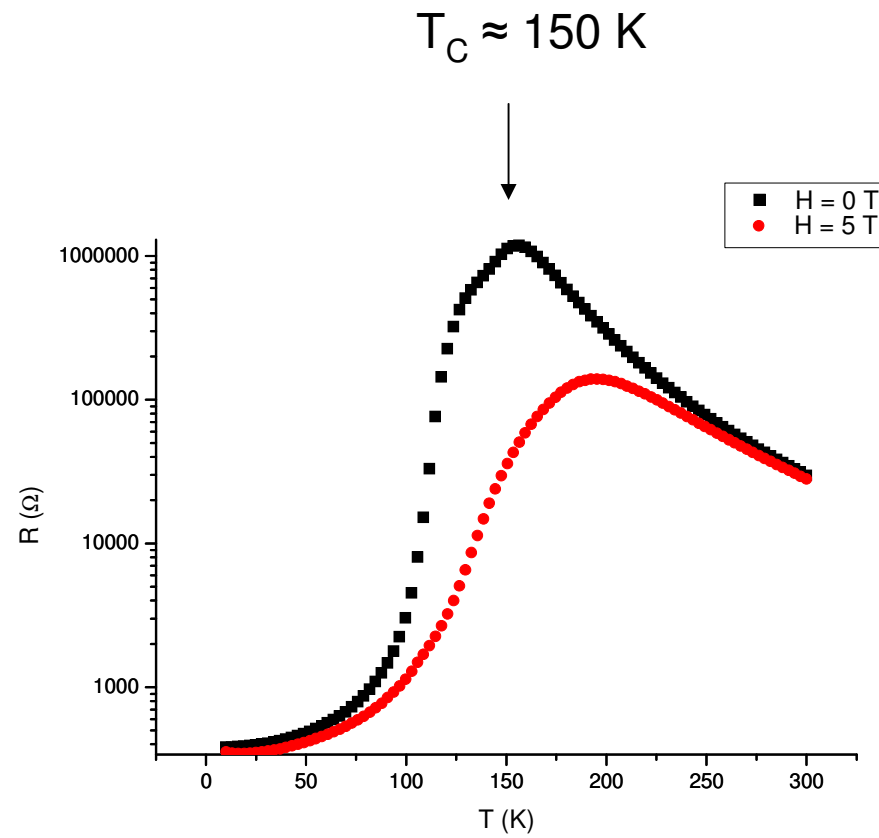


Above T_C : activated polaron hopping

Below T_C : e_g electrons delocalize, onset of spin ordering



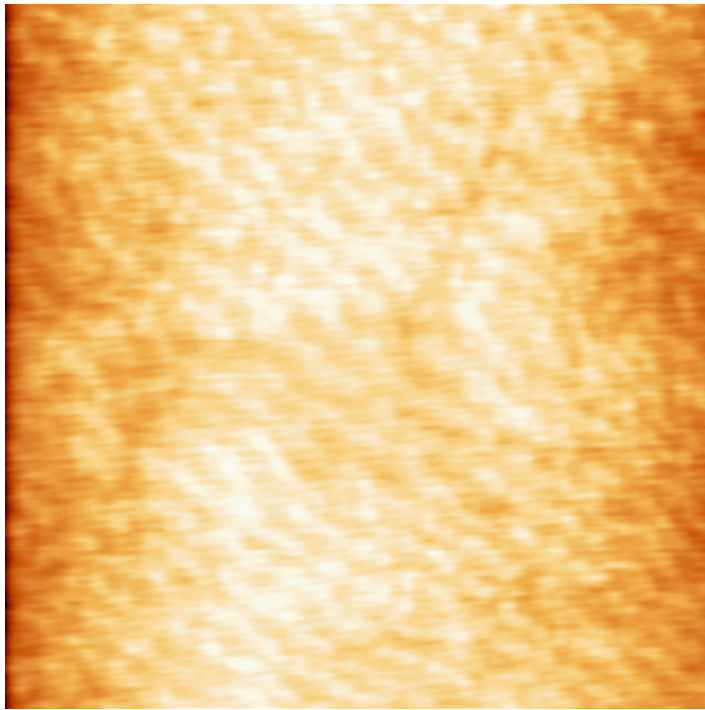
External field : different magnetic domains align reducing resistance, CMR effect



Bulk : $T_C \approx 270$ K \rightarrow lattice mismatch with STO substrate causes strain which reduces T_C

Miscut substrates

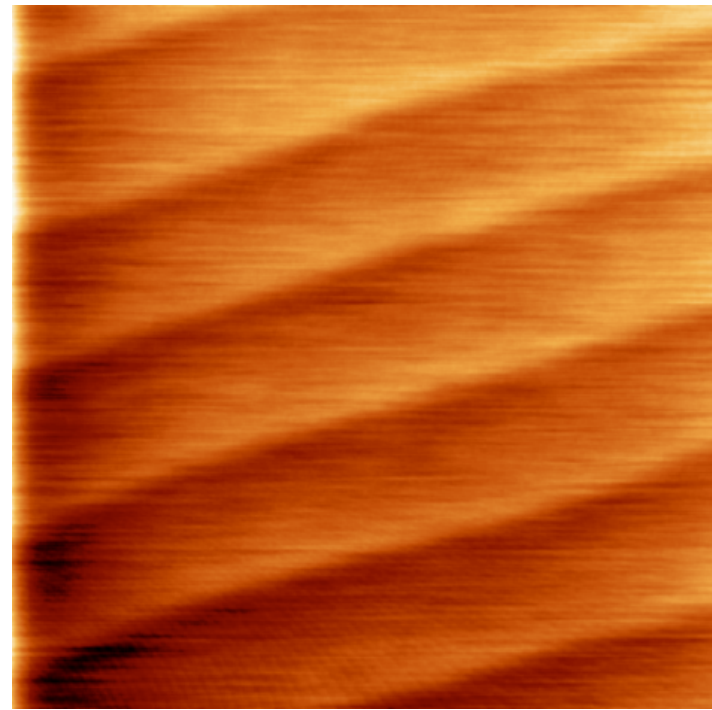
AFM picture of 0.2° miscut substrate



← 2.3 x 2.3 μm →

No visible steps

AFM picture of 0.18° miscut substrate terminate layer TiO_2

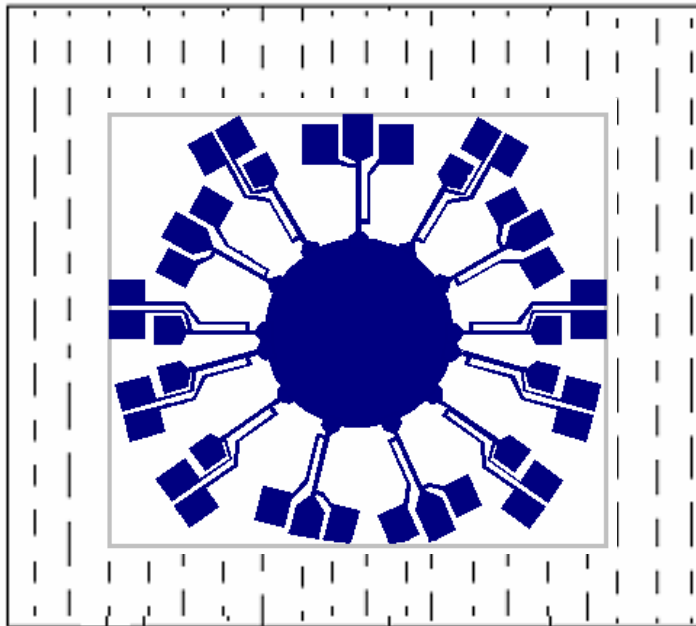


← 737 x 737 nm →

Clearly visible steps

Miscut substrates

Optical lithography



Structure sizes:

Diameter: ~ 5 mm

Contactpads: $\sim 350 \times 400$ μm

Strips: $w = \sim 40$ μm
 $l = \sim 500$ μm

T_C reduction:

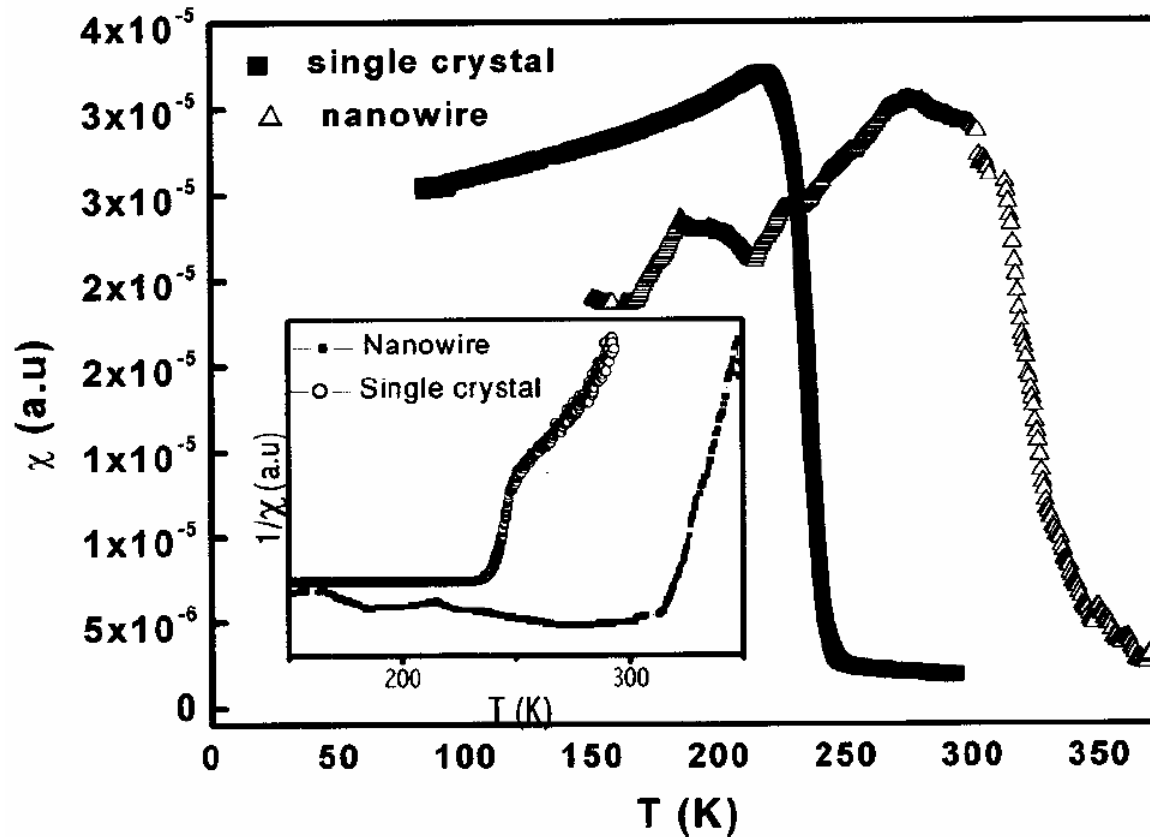
- ✓ Strain due to lattice mismatch with substrate
- ✓ Internal “chemical” pressure: decrease radius dopant ions

T_C enhancement:

- ✓ External pressure: oxygen ions more densely packed
- ✓ Reduction of sample size: nanopowders & nanowires

LCMO nanowires

Shankar et al. Appl. Phys. Lett., Vol. 84, No. 6, 9 February 2004

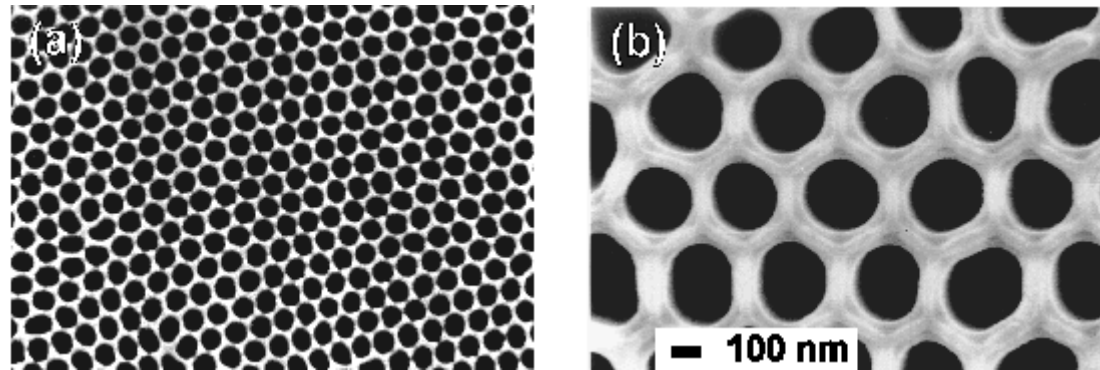


Nanowire: T_c is enhanced compared to bulk single crystal

LCMO nanowires

Growth process: Sol-gel

Polymer assisted nucleation of cation complex in pores of alumina templates



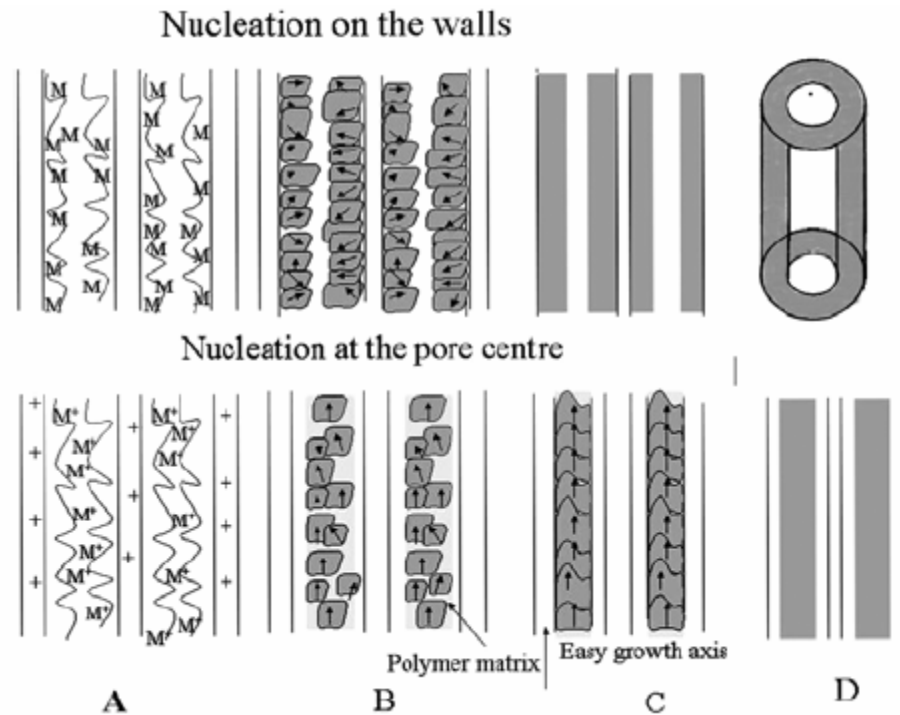
Sol: La_2O_3 , CaCO_3 , $\text{Mn}(\text{NO}_3)_2$ & ethylene glycol

LCMO nanowires

Shankar et al. nanotech., Vol. 15, 1312, 2004

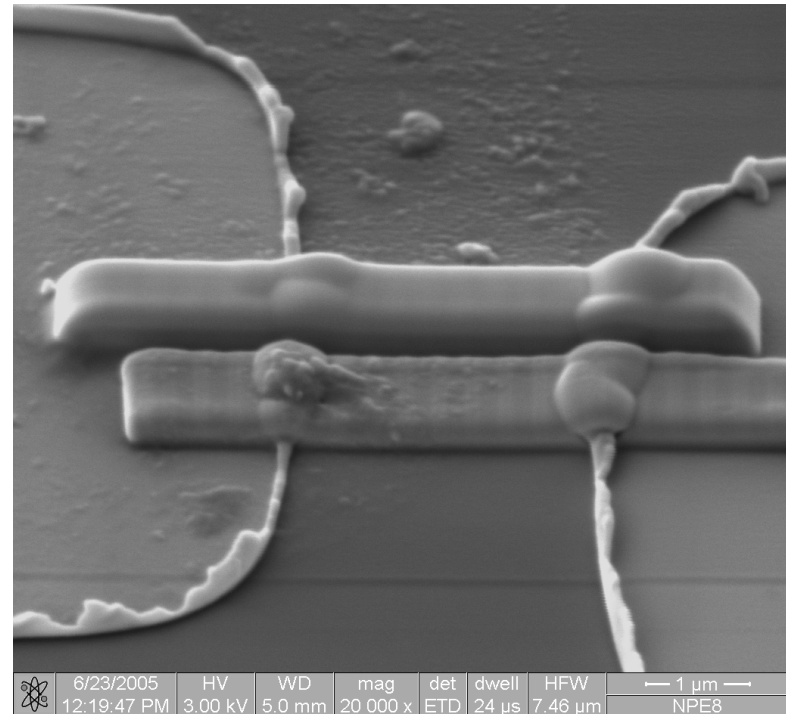
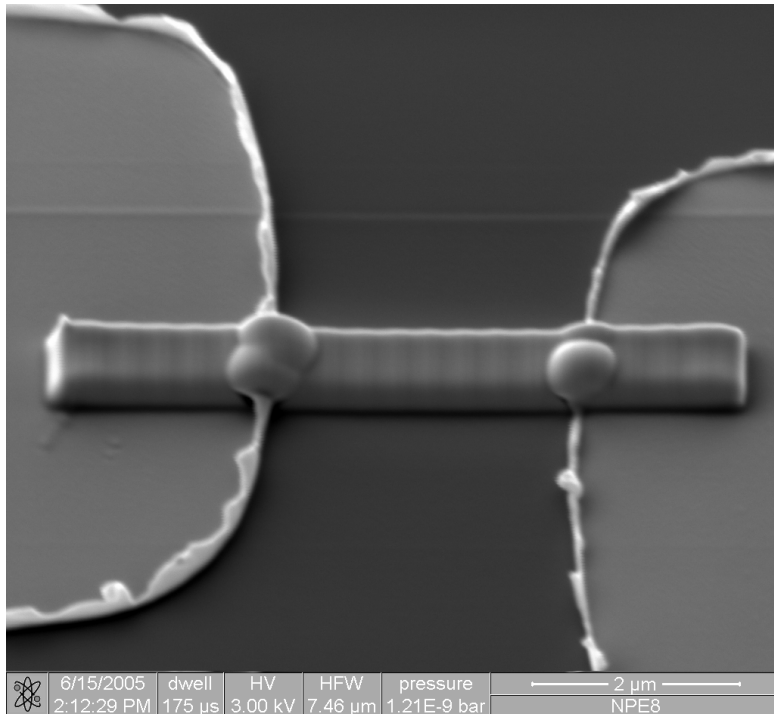
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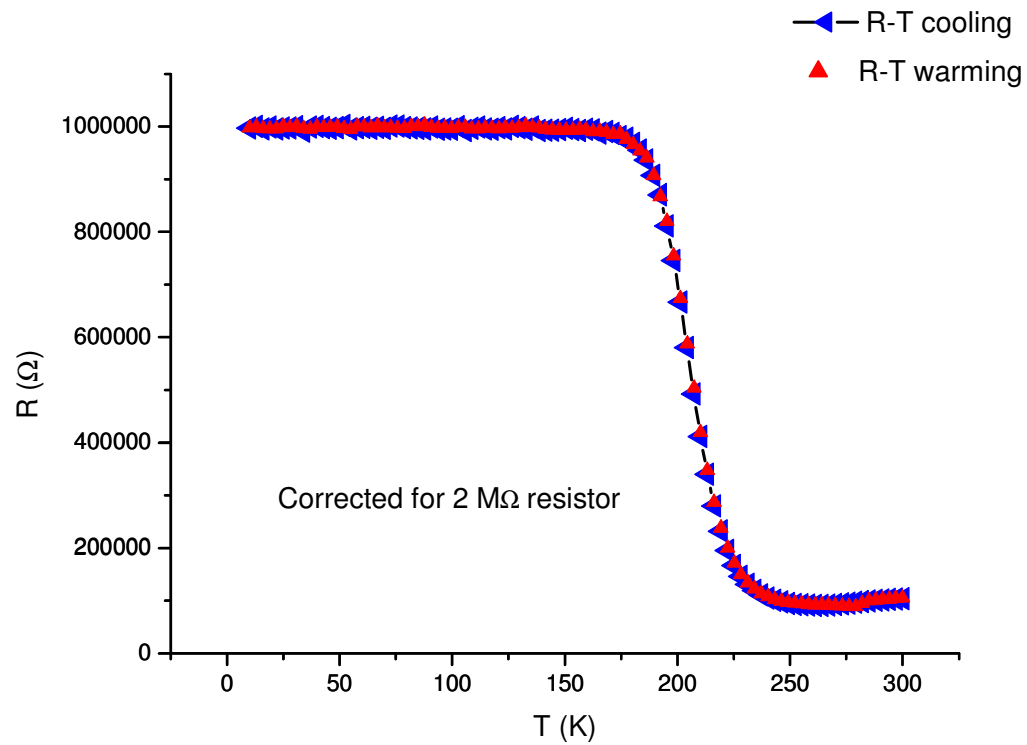
Pt as a contact material

Contact geometry can be written with FEI nanosem

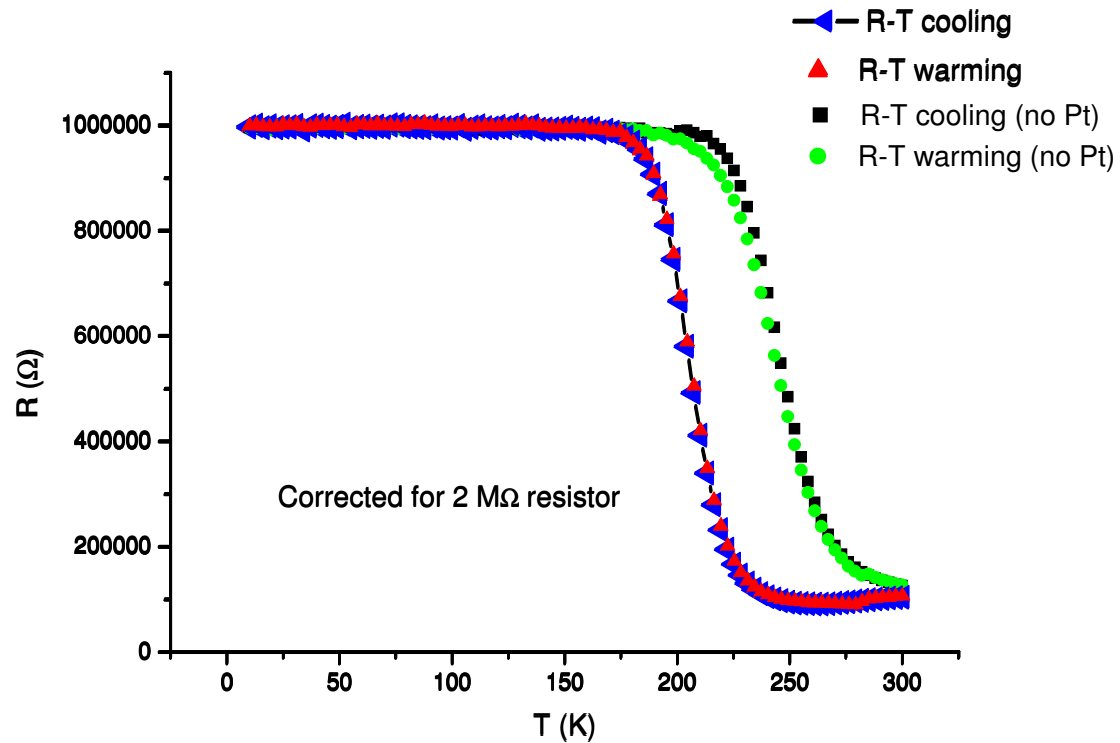


Pt strip: $t = 500 \text{ nm}$
 $w = 800 \text{ nm}$
 $l = 6.5 \text{ μm}$

Pt as a contact material



Pt as a contact material

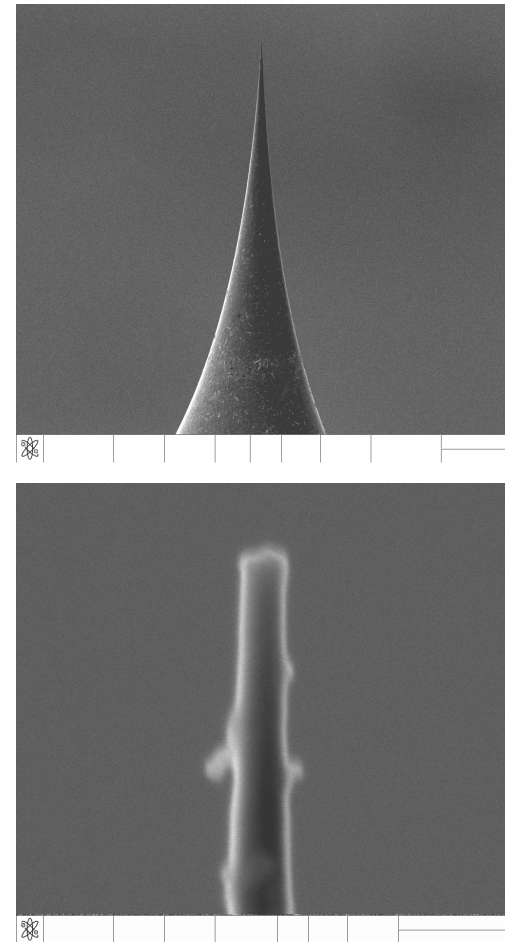
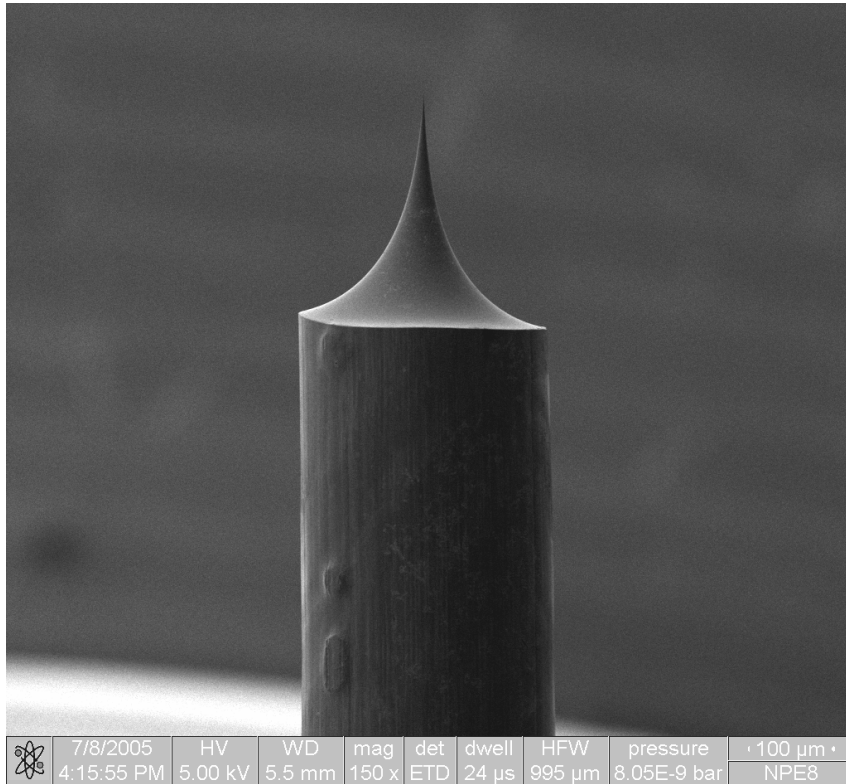


Measuring substrate instead of Pt strip

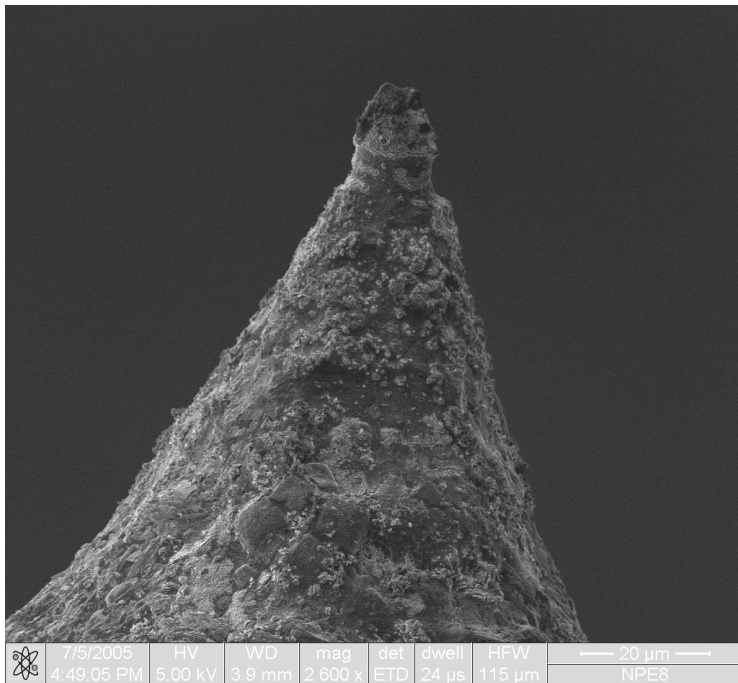
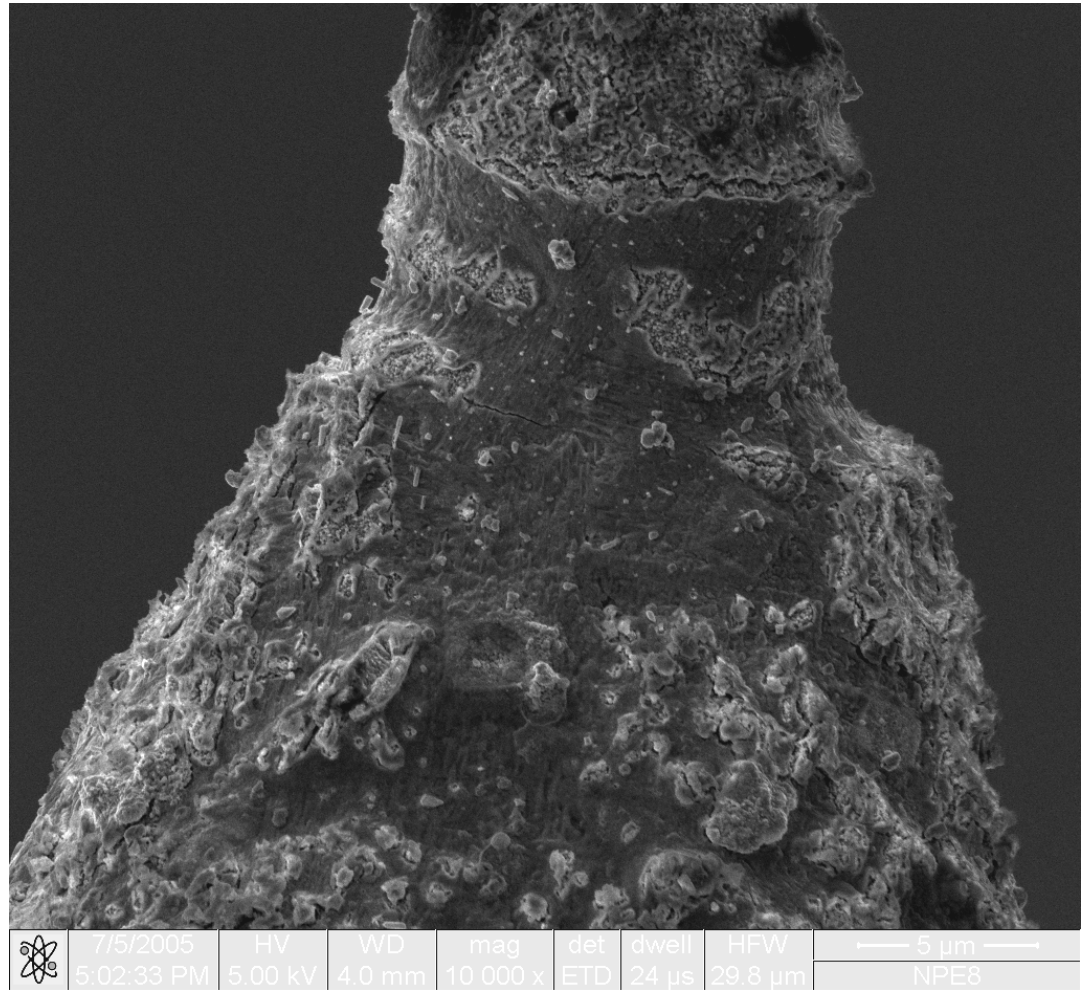
Bad interface?

Future research

- ✓ Surface treatment for miscut substrates
- ✓ Measure the transport properties of LCMO strip for different angles relative to terraces
- ✓ Develop the sol-gel procedure for the growth of LCMO nanowires

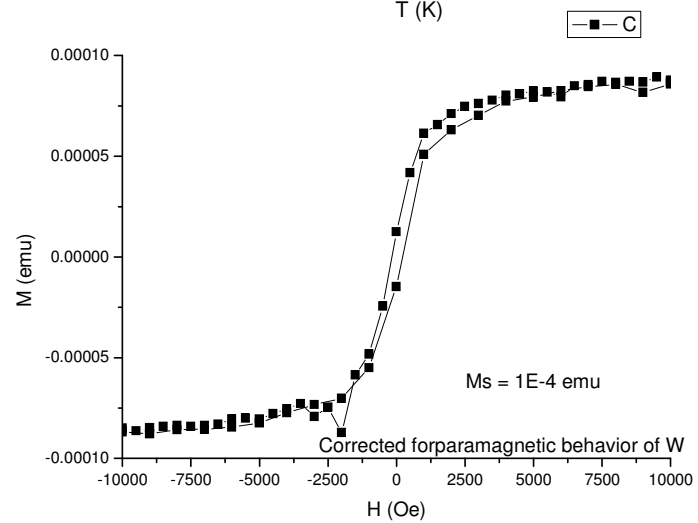
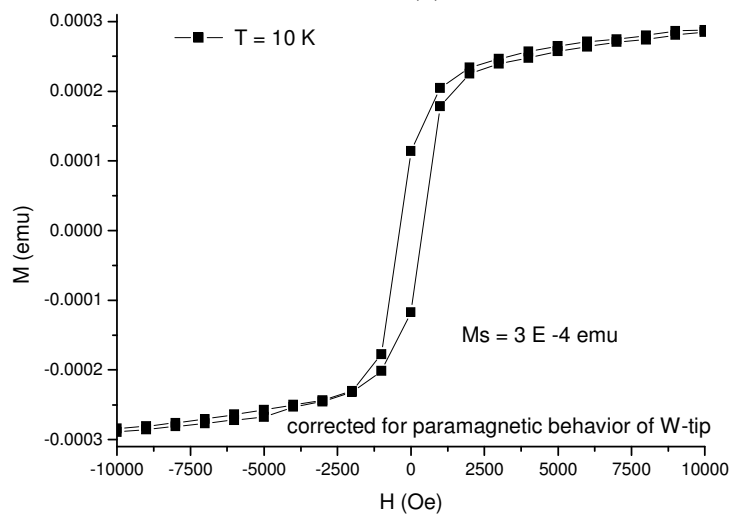
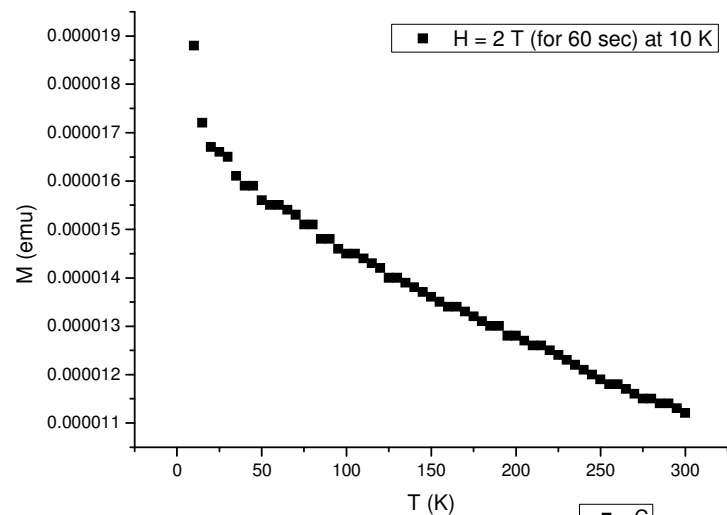
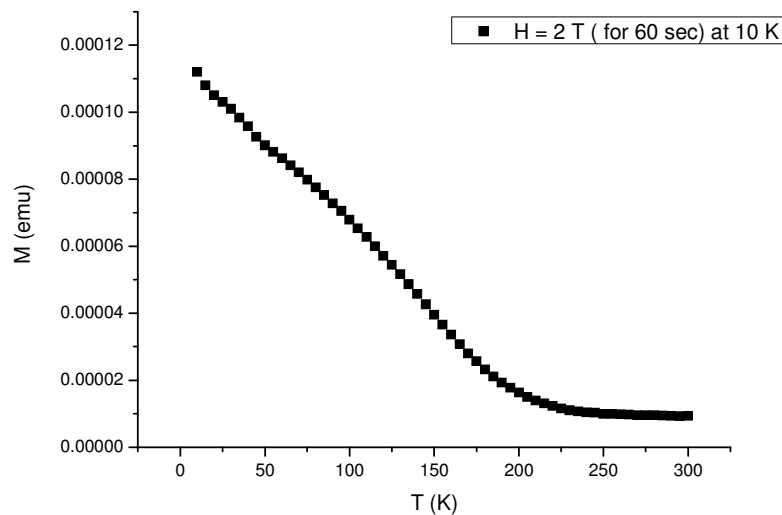


Tip radius of curvature $\sim 136 \text{ nm}$
Needle has same tree like surface as the coated tip (LCMO) suggesting LCMO only grows near the tip.



SEM imaging of LCMO ($\text{La}_{0.67}\text{Ca}_{0.33}\text{MnO}_3$) coated W-tip
 During sputtering cooling water was leaking into the vacuum, probably causing corrosion.
 Expected layer thickness 25-50 nm (sputter rate 50nm/hour)

From images:
 tip radius of curvature $\sim 6 \mu\text{m}$ (before coating radius of curvature should be $\sim 20 \text{ nm}$)
 roughness order of magnitude $\sim 1 \mu\text{m}$



W-tip coated with LCMO

Bare W-tip